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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Reissue Application of: Shunichi SATO

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For: METHODS FOR GROWING SEMICONDUCTORS AND DEVICES THEREOF
FROM THE ALLOY SEMICONDUCTOR GaInNAs

Examiner: Laura M. Menz

Group Art Unit: 2813

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Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

**APPLICANT'S COMMENTS ON
EXAMINER'S STATEMENT OF REASONS FOR ALLOWANCE**

Sir:

Applicant appreciates the Examiner's Statement of the Reasons for Allowance attached to the Notice of Allowability dated January April 20, 2010 and submits that the allowed claims recite subject matter which further supports patentability for reasons in addition to those identified in the Reasons for Allowance.

Respectfully submitted,

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I hereby certify that this correspondence is being deposited this date with the U.S. Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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July 19, 2010

Date